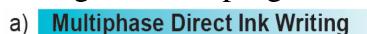
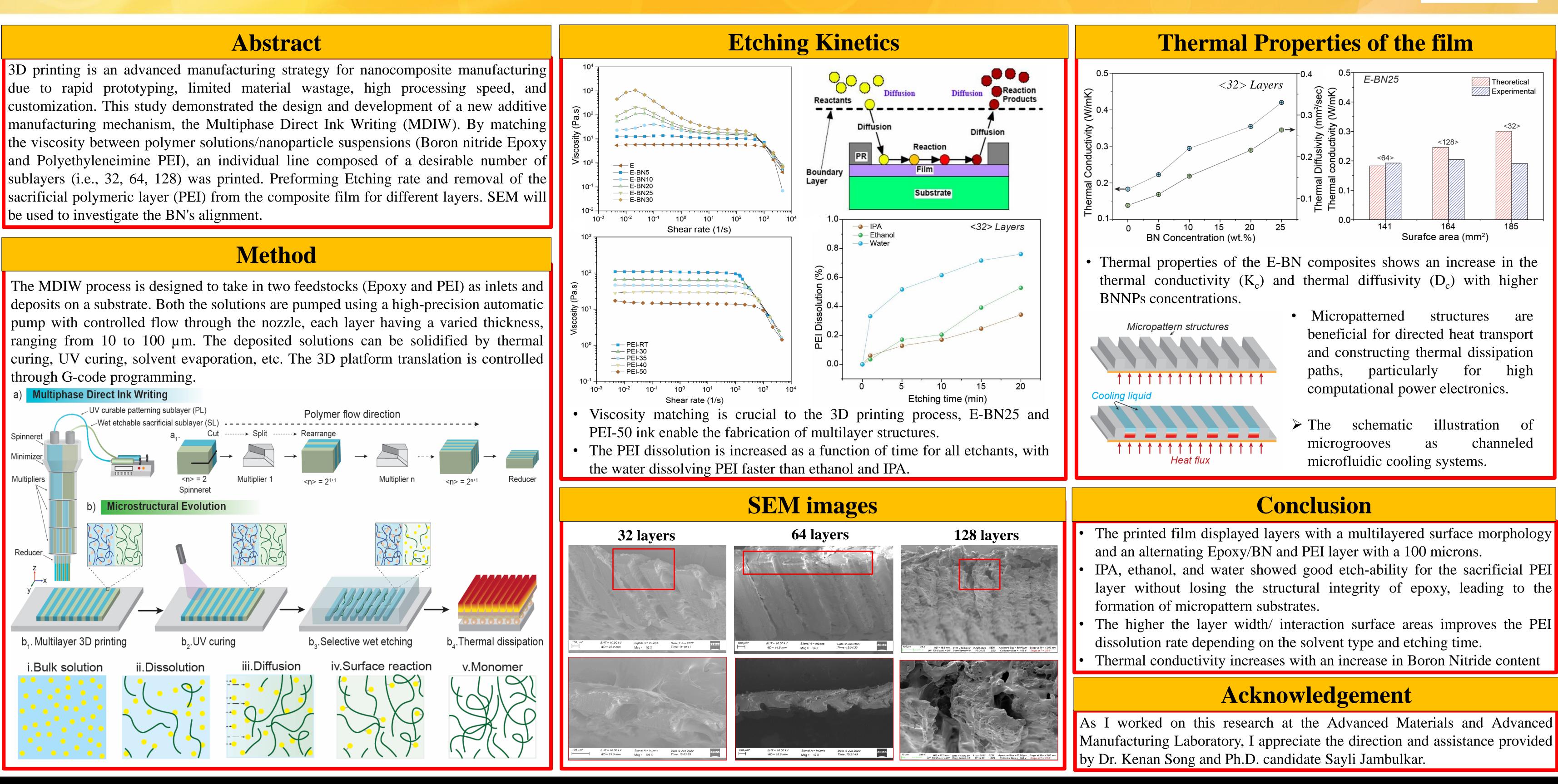
Micropatterning of Nanoparticles via Multi-Phase Direct Ink Writing (MDIW)







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- The printed film displayed layers with a multilayered surface morphology
- layer without losing the structural integrity of epoxy, leading to the
- The higher the layer width/ interaction surface areas improves the PEI

